

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date of NOA:

Art Unit:

In re application of:

Yoshihiro BASHO, et al

Serial No:

10/758,302

Filed: January 15, 2004

For:

Heat Releasing Member, Package for

Accommodating Semiconductor Element

and Semiconductor Device

TRANSMITTAL OF ISSUE FEE

Mail Stop ISSUE FEE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Mail Stop ISSUE FEE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450, on June 3, 2005

2815

to:

Date of Deposit

March 21, 2005

I hereby certify that this correspondence is being deposited with the United States

Postal Service with sufficient postage as

first class mail in an envelope addressed

Wendy McLaren

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In response to the Notice of Allowance dated March 21, 2005, enclosed are the following:

Form Part B - Issue Fee Transmittal, Advance Order for 10 patent copies and a check in the X amount of \$\(\frac{1730.00}{\) in payment of the Issue Fee, Publication Fee and Advance Order.

Comments on Statement of Reasons for Allowance. X

The Commissioner is hereby authorized to charge any deficiency in payment or credit any overpayment to Deposit Account No. 50-1314. A copy of this Transmittal is enclosed.

Respectfully submitted,

HOGAŃ& HARTSON L.L.F

Date: June 3, 2005

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Patent Application No. 10/758,302 Attorney Docket No. 81716.0117

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Wendy McLaren

6/3/DS

Dear Sir:

In the Notice of Allowance dated March 21, 2005, the Office stated that:

"The reference (s) of record do not teach or suggest either singularly or in combination at least one limitation of . . . "wherein in the heat releasing member, a plurality of through metal members made a plate like substrate made of a matrix of tungsten or molybdenum and copper to another surface, copper layers are joined at least to one and other surfaces of a portion in which the through metal members of the substrate are buried, and a cross section area of each of the through metal members is gradually increased from the center side of the substrate to a joint portion with the copper layers."

Applicant notes that the quoted portion of claim 10 is inaccurate in that it omits a limitation contained in claim 10. Namely, the quoted section of paragraph 10 should read:

"wherein in the heat releasing member, a plurality of through-metal members made of a copper are buried from one surface of the mounting portion of a plate-like substrate made of a matrix of tungsten or molybdenum and copper to another surface, copper layers are joined at least to one and other surfaces of a portion in which the through-metal members of the substrate are buried, and a cross-section area of each of the through-metal members is gradually increased from the center side of the substrate to a joint portion with the copper layers." (underlining added to show omitted limitation.)

Respectfully submitted,

HOGAN & HARTSON L.L.P.

 $\mathbf{R}_{\mathbf{V}}$

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Date: June 3, 2005